



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
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COMPLETE IF KNOWN

Application Number	10/606,992
Confirmation Number	
Filing Date	June 25, 2003
First Named Inventor	Dan Daeweon Cheong
Group Art Unit	
Examiner Name	
Attorney Docket No.	356828001US1

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
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Examiner Initials*	Cite No.	Foreign Patent or Application			Name of Patentee or Applicant of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	NUMBER	Kind Code (if known)				
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OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
		PATENT ABSTRACTS OF JAPAN, Vol. 013, No. 069 (C-569), 16 February 1989, Abstract of Application No. 62091399.	
TAM		Eguchi, K., et al., "Composition Self-Matching Phenomena in Chemical Vapor Deposition of Thin Films," Electrochemical Society Proceedings, Vol. 98-3, p.179-189.	
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EXAMINER	DATE CONSIDERED 12/21/04
*EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application(s).	